

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/806,269	SIPPOLA, MIKA
	Examiner	Art Unit
	Marcos D. Pizarro-Crespo	2814

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
PGPub text search. See interference search printout.		12/14/2006	MDP